

Docket No.: 50103-537

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
	:	
KURATAKA, NOBUO, et al.	:	
	:	
Serial No.: Unassigned	:	Group Art Unit: Unassigned
	:	
Filed: Concurrently Herewith	:	Examiner: Unassigned
	:	
For: METHOD FOR PROTECTING SURFACE OF STAMPER/IMPRINTER DURING MANUFACTURE THEREOF		

APPLICATION DATA SHEET

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following inventor bibliographic information is submitted in accordance with
the provisions of 37 CFR 1.76 and MPEP 6 01.05.


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